

UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/847,667	05/01/2001	Subhash Gupta .	54364	4777
75	590 12/04/2003	EXAMINER		
	ces of Calvin B. Ward	MITCHELL, JAMES M		
Suite 305 18 Crow Canyo	n Court	ART UNIT	PAPER NUMBER	
San Ramon, CA 94583			2827	

DATE MAILED: 12/04/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

. , ,		Арр	lication No.	Applicant(s)	Applicant(s)	
Office Action Summary		09/8	347,667	GUPTA ET AL. Art Unit		
		Exar	nin r			
			es M. Mitchell	2827		
Period fo	The MAILING DATE of this commu	ınication appears o	on the cover sheet v	vith the correspondence addr	ess	
A SH THE - Exte after - If the - If NO - Failu - Any I	ORTENED STATUTORY PERIOD MAILING DATE OF THIS COMMUNITY OF THIS CO	NICATION. ns of 37 CFR 1.136(a). In nmunication. (30) days, a reply within the statutory period will apply ly will, by statute cause the	no event, however, may a the statutory minimum of th and will expire SIX (6) MO	reply be timely filed irty (30) days will be considered timely. NTHS from the mailing date of this comm.	nunication.	
1)	Responsive to communication(s)	filed on 07 July 20	ากร			
2a)□	This action is FINAL .	2b)⊠ This actio				
3)	Since this application is in condition			ottore proposition == t= t		
•—	closed in accordance with the pra on of Claims	ctice under Ex par	te Quayle, 1935 C	D. 11, 453 O.G. 213.	nents is	
4)🖾	Claim(s) 1-10 is/are pending in the	application.				
	4a) Of the above claim(s) is/	are withdrawn fror	n consideration.			
5)□	Claim(s) is/are allowed.					
6)⊠	Claim(s) <u>1-10</u> is/are rejected.					
7)	Claim(s) is/are objected to.					
	Claim(s) are subject to restri	ction and/or electi	on requirement.			
	on Papers					
	he specification is objected to by the					
10) ⊠	he drawing(s) filed on <u>01 May 200</u>					
44)[] 7	Applicant may not request that any ob					
11)[11	he proposed drawing correction file			disapproved by the Examiner.		
12\[7	If approved, corrected drawings are re					
	he oath or declaration is objected to	o by the Examiner	•			
	nder 35 U.S.C. §§ 119 and 120					
	Acknowledgment is made of a claim	n for foreign priorit	y under 35 U.S.C.	§ 119(a)-(d) or (f).		
	All b) Some * c) None of:					
	1.☐ Certified copies of the priority					
	2. Certified copies of the priority					
	 Copies of the certified copies application from the Interret ee the attached detailed Office action 	national Bureau (P	CT Rule 17.2(a)).		ge	
	cknowledgment is made of a claim f				plication)	
_ a)	☐ The translation of the foreign lan	nguage provisiona	l application has b	een received.		
ttachment(•	_			
) 🔲 Notice	of References Cited (PTO-892) of Draftsperson's Patent Drawing Review (F ation Disclosure Statement(s) (PTO-1449) P	PTO-948)	4) Interview 5) Notice of I	Summary (PTO-413) Paper No(s) nformal Patent Application (PTO-15	<u> </u>	

Art Unit: 2827

DETAILED ACTION

Claim Rejections - 35 USC § 112

The following is a quotation of the first paragraph of 35 U.S.C. 112:

The specification shall contain a written description of the invention, and of the manner and process of making and using it, in such full, clear, concise, and exact terms as to enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make and use the same and shall set forth the best mode contemplated by the inventor of carrying out his invention.

Claims 1-10 are rejected under 35 U.S.C. 112, first paragraph, because the specification does not enable any person skilled in the art to which it pertains, or with which it is most nearly connected, to make or use the invention commensurate in scope with these claims.

The invention involves unpredictable chemical reactions through the use of CMP, a wafer material and a stop layer. Absent a statement applicable to the genus as a whole, it is indeterminable from the disclosure of the particular species what other species will work; hence, it is indeterminable what other species are members of the genus. As a result, a person skilled in the art could not make the genus as a whole without undue experimentation. Chemical reactivity is a most unpredictable and empirical art and it is well settled that the requirement that the claims be commensurate in scope with the enabling disclosure is particularly stringent in this area of technology. See In re Doumani 126 USPQ 408, In re Grant 134 USPQ 248, In re Fisher 166 USPQ 18, Mobil Oil Corporation v. W. R. Grace and Company 180 USPQ 418, In re Slocombe 184 USPQ 740, In re Mercier 185 USPQ 774, Corona Cord Tire Company v. Dovan Chemical Corporation 192 CD 255 and In re Hawkins 174 USPQ 157.

Application/Control Number: 09/847,667

Art Unit: 2827

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 1-3 and 5-7 are rejected under 35 U.S.C. 102(e) as being anticipated by Schrems (US 2002/0125521).

Schrems (Fig 1; Claims 8, 9) discloses an integrated circuit wafer comprising; a substrate comprising a wafer material ("wafer" not labeled), said substrate having first and second surfaces, said first surface having a circuit layer comprising integrated circuit elements (112, 113, 114) constructed thereon; a plurality of vias (space taken by "capacitors"; Par. 0076) extending a first distance from said first surface of said substrate into said substrate, said first distance being less than the distance between said first and second surfaces of said substrate, said vias having a bottom surface comprising: a stop layer ("tungsten nitride") covering said bottom surface, said stop layer comprising material that is more resistant to CMP than said wafer material; and wherein said wafer material comprises silicon (Par. 0011); and vias lined with a layer of an electrically insulating material (164); and said vias are filled with a tungsten, electrically conducting material (161); wherein a dielectric layer (189) having top and bottom surfaces, said dielectric layer covering said circuit layer such that said bottom surface is in contact with said integrated circuit layer; and a plurality of electrical

Application/Control Number: 09/847,667

Art Unit: 2827

conductors (183) buried in said dielectric layer and making electrical connections to said integrated circuit elements.

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-3 and 7-10 are rejected under 35 U.S.C. 102(b) as being anticipated by Clements (US 4,054,875).

Clements discloses a wafer material (10), said substrate having a first and second surface, the first surface having a circuit layer comprised of an integrated circuit formed thereon (Lines 26-27, Column 1; Lines 56-57, Column 8) with an inherent dielectric layer having a top and bottom, such that a bottom surface is in contact with said integrated circuit layer (via conventional IC fabrication) covering circuit layer, a plurality of vias (Fig.1, Item 25) extending a first distance from said first surface (Shown more clearly in Fig. 12); said first distance being less than the distance between said first and second surfaces of said substrate, said vias having a bottom surfacecomprising an insulating, etch stop layer that is lined on said bottom surface, said vias comprising a Si_vN_z stop layer ("etch resistant"; Fig 9; Item 40) that inherently provides a more resistant to chemical/mechanical polishing than said wafer material, the via filled with an electrically conductive material (Lines 1-2, Column 10); with the vias terminating in an electrically conducting pad (22, 33) with the wafer, the integrated circuit inherently being formed beneath the pad (Lines 49-50, Column 6), and an electrical conductor (the conductive material in the via) connected electrically to said via (Fig. 9); wherein at least one via extends through the dielectric layer.

Art Unit: 2827

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claim 4 rejected under 35 U.S.C. 103(a) as being unpatentable over Schrems (US 2002/0125521).

Schrems does not appear to explicitly disclose the insulating layer is silicon dioxide, however examiner takes official notice that silicon dioxide was well known in the art at the time of present invention and that it would have been obvious to one of ordinary skill in the art to form the insulating layer of Schrems as a silicon dioxide in order to provide an oxide as required by Schrems (Claim 8).

Response to Arguments

Applicant's arguments with respect to claims have been considered but are moot in view of the new ground(s) of rejection.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to James M. Mitchell whose telephone number is (703) 305-0244. The examiner can normally be reached on M-F 10:30-8:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kamand Cuneo can be reached on (703) 308-1233. The fax phone number for the organization where this application or proceeding is assigned is (703) 872-9306.

Application/Control Number: 09/847,667

Art Unit: 2827

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

th & 2000

Page 6

DAVID E. GRAMINER PAMINAX3 YRAMING